

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Wen-Yen Hwang and Stefan J. Murry

Application No.:

Filed: Herewith

Title: Method and Apparatus for Reducing
Specular Reflections in Semiconductor
Lasers

§ Group Art Unit: Unassigned
§
§
§ Examiner: Unassigned
§
§ Confirmation No.: Unassigned
§
§ Atty Docket No. PAT030
§



Box PATENT APPLICATION
Commissioner for Patents
Washington, D.C. 20231

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Yvonne R. Dimera
Signature

INFORMATION DISCLOSURE STATEMENT

In compliance with the information disclosure statement requirements of 37 C.F.R. § 1.56
and 1.97, Applicant hereby submits the attached references related to the above-identified
application.

Date: 7-26-01

Respectfully submitted,

N. Stephan Kinsella

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